

WEST Search History

DATE: Wednesday, June 18, 2003

Set Name Query

side by side

Hit Count Set Name

result set

DB USPT,PGPB,JPAB,EPAB,DWPI,TDBD; PLUR YES; OP ADJ

L28	L27 and ((increase\$3 or grow\$4) near3 time)	5	L28
L27	L26 or (6004047.pn) or (6331890.pn.)	26	L27
L26	L25 or (5923429 pn) or (6002485.pn)	22	L26
L25	L24 or (5751896 pn) or (5818596.pn)	18	L25
L24	L22 or (5624190 pn) or (5740034.pn)	14	L24
L23	L22(5624190.pn.) or (5740034.pn.)	2	L23
L22	L21 or (5393624 pn) or (5399229.pn)	10	L22
L21	(5131752.pn.) or (5313044.pn.)	4	L21
L20	L19 and ((increase\$3 or grow\$4) near3 time)	7	L20
L19	(thin adj oxide\$2) and (thickness near4 measur\$6 near3 time) and ((air or atmospher\$4) near3 oxid\$6)	9	L19
L18	5166752 pn.	2	L18
L17	L13 and (ln or log)	2	L17
L16	L13 and ((increase\$3 or grow\$4) near3 time near3 (ln or log))	0	L16
L15	L14 and (time)	14	L15
L14	L13 and ((increase\$3 or grow\$4) near3 time)	14	L14
L13	(thin adj film) and (thickness near4 measur\$6 near3 time) and ((air or atmospher\$4) near3 oxid\$6)	23	L13
L12	L11 and time	3	L12
L11	L9 and ((log or ln) with (increas\$5 or grow\$3))	3	L11
L10	L9 and (log or ln)	45	L10
L9	(thin adj film) and (thickness near4 measur\$6) and ((air or atmospher\$4) near3 oxid\$6)	657	L9
L8	L7 and (thickness\$3 with grow\$3)	3	L8
L7	L6 or (5354575.pn.) or (5506178.pn.)	13	L7
L6	L5 or (5132244.pn.) or (5352636.pn.)	8	L6
L5	L1 or L2 or (4717446.pn.)	4	L5
L4	L3 and (log or ln)	0	L4
L3	semiconductor and ((oxide near3 measur\$6 near4 thick\$5) with air)	5	L3
<i>DB USPT,PGPB; PLUR YES; OP ADJ</i>			
L2	5751582.pn.	1	L2
L1	4395438.pn.	1	L1

END OF SEARCH HISTORY